



Docket #: 60188-0431

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
Akihiko ISHIBASHI, et al.	:	Confirmation Number: 6491
Serial No.: 10/017,389	:	Group Art Unit: 2818
Filed: December 18, 2001	:	Examiner: Mai Huong C. Tran
For: METHOD FOR FABRICATING SEMICONDUCTOR, METHOD FOR FABRICATING SEMICONDUCTOR SUBSTRATE, AND SEMICONDUCTOR LIGHT EMITTING DEVICE	:	

PATENT
RECEIVED
SEP 23 2003
TECHNOLOGY CENTER 2000

AMENDMENT

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated July 22, 2003, having a three-month shortened statutory period for response set to expire on October 22, 2003, reconsideration of the above-identified application is respectfully requested in view of the following amendment and remarks.